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patent attorneys

November 6, 2006



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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/615,842 for  
DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS  
Our Ref. No. 421/170/8/2 CIP

Sir:

Please find enclosed the following:

1. Response to Restriction Requirement (3 pages);
2. A return-receipt postcard to be returned to our offices with the U.S. Patent and Trademark filing stamp thereon; and
3. A Certificate of Express Mail No.: EV 974208002 US.

Please contact our offices if there are any questions with this matter.

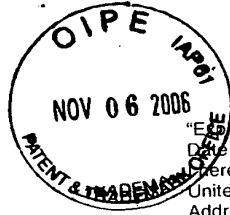
Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

*JLW*

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Enclosures

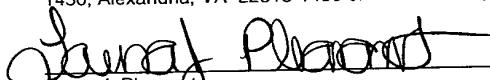


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Laura J. Pleasants  
Date of Signature November 6, 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Oh et al.

Group Art Unit: 1753

Serial No.: 10/615,842

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

\* \* \* \* \*

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Restriction/Election Requirement dated October 11, 2006, having a 1-month term for Response up to and including November 11, 2006. Favorable consideration is respectfully requested in view of the following Election and Remarks.

RESTRICTION PRESENTED

The claims have been restricted into the following groups of inventions:

<u>Groups</u>	<u>Claims</u>	<u>Subject Matter</u>
I	1-30, 32-62	drawn to a method of depositing a pattern, classified in class 204, subclass 490
II	31	drawn to product, classified in class 428

APPLICANTS' ELECTION

Applicants hereby elect the invention of Group I, claims 1 through 30 and 32 through 62, drawn to a method of depositing a pattern, classified in class 204, subclass 490, for prosecution at this time.

REMARKS

Claims 1-62 are now pending in the subject U.S. patent application. Claims 1-62 as filed have been subjected to a Restriction/Election Requirement.

In response to the Restriction/Election Requirement, applicants have elected the claims of Group I, claims 1-30 and 32-62, for prosecution at this time.

Applicants hereby reserve the right to file one or more divisional patent applications directed to the non-elected subject matter.